

Group Art Unit: 2818

Application No.: 10/823,729 Examiner: David Vu

Filed: April 14, 2004 Confirmation No.: 5344

For: SEMICONDUCTOR DEVICE FABRICATION METHOD

In re the Application of: Tadashi WATANABE et al.

Attorney Docket Number: 042341

Customer Number: 38834

AMENDMENT UNDER 37 C.F.R. §1.111

Mail Stop Amendment Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450 December 6, 2005

Sir:

This Amendment is in response to the Office Action of September 7, 2005, having a response due date set for December 7, 2005. The following amendments and remarks are respectfully submitted.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 13 of this paper.